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PATENT
Attorney Docket No. 01-099

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
JUL 28 2003
GROUP 1700

In re Application of:)	
Rongxiang Hu, Philippe Schoenborn,)	
and Masaichi Eda)	Group Art Unit: 1765
)	
Serial No. 09/928,570)	Confirmation No. 7873
)	
Filed: August 13, 2001)	Examiner: L. Umez-Eronini
)	
For: HIGH SELECTIVELY SiC ETCH)	
IN INTEGRATED CIRCUIT)	
FABRICATION)	

AMENDMENT AND RESPONSE TO FIRST OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed March 31, 2003, please amend the application as set forth below in the Two Parts of this Amendment and Response.

IN THE CLAIMS:

Amend claims 1-6 and 8-11.

Part 1 hereof presents the claims with markings to indicate the changes.

REMARKS

Part 2 comments on the above amendments, and the March 31, 2003 office action.